



#22

INFORMATION CITED BY APPLICANTS THAT MAY BE MATERIAL TO THE
PROSECUTION OF THE SUBJECT APPLICATION

Applicants: L.W. Graham et al. Attorney Docket No.: SEMT116060
Application No.: 09/429,446 Group Art Unit: 1741
Filed: October 28, 1999 Examiner: W. Leader
Title: METHOD, CHEMISTRY, AND APPARATUS FOR NOBLE METAL
ELECTROPLATING ON A MICROELECTRONIC WORKPIECE

U.S. PATENT DOCUMENTS

*Examiner Cite Initials No.	Document No.	Kind Code	Date (mm/dd/yyyy)	Name
<u>WL</u> U20	5,789,320		08/04/1998	Andricacos et al.

Examiner

William Leader

Date Considered

9/2002

*Examiner: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

JMS:mc

RECEIVED
JUL 10 2002
TC 1700

LAW OFFICES OF
CHRISTENSEN O'CONNOR JOHNSON KINDNESS^{PC}
1420 Fifth Avenue
Suite 2800
Seattle, Washington 98101
206.682.8100